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Substitute for form 1449/PTO				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)				Application Number	TBD
				Filing Date	Herewith
				First Named Inventor	Hsu, et al.
				Art Unit	TBD
				Examiner Name	TBD
Sheet	1	of	2	Attorney Docket Number	TSM02-1205

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
3		US-6,346,490 B1	02-12-2002	Catabay, et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)				

Examiner Signature	<i>J. M. [Signature]</i>	Date Considered	<i>7. 5</i>
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Substitute for form 1449B/PTO		<b>Complete if Known</b>	
		Application Number	TBD
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>		Filing Date	Herewith
		First Named Inventor	Hsu, <i>et al.</i>
		Group Art Unit	TBD
		Examiner Name	TBD
		Attorney Docket Number	TSM02-1205
Sheet	2	of	2

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	<sup>2</sup>
		Yang, S., <i>et al.</i> , "Processing and Characterization of Ultralow-Dielectric Constant Organosilicate," J. Vac. Sci. Technol. B, Vol. 19, No. 6 (Nov/Dec 2001) pp. 2155-2161.	
		Terry, J., <i>et al.</i> , "Alkyl-terminated Si(111) Surfaces: A High-Resolution, Core Level Photoelectron Spectroscopy Study," Journal of Applied Physics, Vol. 85, No. 1 (January 1, 1999) pp. 213-221.	
		Chang, T.C., <i>et al.</i> , "Eliminating Dielectric Degradation of Low-k Organosilicate Glass by Trimethylchlorosilane Treatment," J. Vac. Sci. Technol. B, Vol. 20, No. 4 (Jul/Aug 2002) pp. 1561-1566.	
		Chang, T.C., <i>et al.</i> , "Trimethylchlorosilane Treatment of Ultralow Dielectric Constant Material After Photoresist Removal Processing," Journal Of The Electrochemical Society, Vol. 149, No. 10 (August 2002) pp. F145-F148.	
		Mor, Y.S., <i>et al.</i> , "Effective Repair to Ultra-Low-k Dielectric Material (k~2.0) by Hexamethyldisilazane Treatment," J. Vac. Sci. Technol. B, Vol. 20, No. 4 (Jul/Aug 2002) pp. 1334-1338.	
		Chang, T.C., <i>et al.</i> , "Recovering Dielectric Loss of Low Dielectric Constant Organic Siloxane During the Photoresist Removal Process," Journal Of The Electrochemical Society, Vol. 149, No. 8 (June 2002) pp. F81-F84.	
		Liu, P., <i>et al.</i> , "Highly Reliable Chemical-Mechanical Polishing Process for Organic Low-k Methylsilsequioxane," J. Vac. Sci. Technol. B, Vol. 19, No. 4 (Jul/Aug 2001) pp. 1212-1218.	
		WOLF, S., "Silicon Processing for the VLSI Era," Vol. 4, Lattice Press, Sunset Beach, California (2002) pp. 639-670.	

Examiner Signature	<i>J. M. M. S.</i>	Date Considered	7-05
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